

IFW PGX

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant(s): Katsuyuki TSUCHIDA et al  
Title : COPPER ELECTROLYTIC SOLUTION CONTAINING AS ADDITIVE  
COMPOUND HAVING SPECIFIC SKELETON, AND  
ELECTROLYTIC COPPER FOIL MANUFACTURED THEREWITH


Serial No. : 10/588 686 Group: 1795  
Confirmation No.: 9917  
Filed : August 7, 2006 Examiner: Wong  
International Application No.: PCT/JP2005/022662  
International Filing Date : December 9, 2005  
Atty. Docket No.: 4700.P0335US

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on January 20, 2009.

  
Terryence F. Chapman

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Heon Jekal  
\*limited recognition number

Reg. No. 25 072  
Reg. No. 32 549  
Reg. No. 36 589  
Reg. No. 40 694  
Reg. No. 24 802  
Reg. No. 36 328  
Reg. No. 43 977  
Reg. No. 24 323  
Reg. No. 24 949  
Reg. No. L0379\*

Correspondence: Supplemental Information Disclosure Statement dated January 20, 2009 including enclosures listed thereon

190.05/05



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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

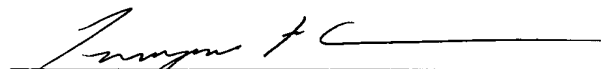
Sir:

In compliance with the provisions of Rules 1.97(b)(3) and 1.98, enclosed herewith is a copy of a Japanese language Office Action issued in a corresponding application not more than three months prior to filing of this Information Disclosure Statement, Form PTO-1449 and a copy of a foreign reference cited thereon.

Further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

Respectfully submitted,

  
Terryence F. Chapman

TFC/ad

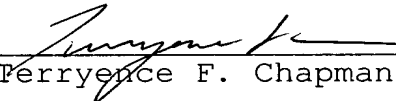
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Encl: Form PTO-1449  
Copy of Japanese language Office Action  
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